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				Application Number	10018727
				Filing Date	Aug 9, 2002
				First Named Inventor	WILLIS, Colin
				Art Unit	1792
				Examiner Name	Padgett, Marianne
Sheet	1	of	1	Attorney Docket No: 41577-266144	

U.S. PATENT DOCUMENTS					
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		Panchalingam, et al., 'Molecular Tailoring of Surfaces via Pulsed RF Plasma Depositions,' <i>J. Biomater. Sci. Polymer Edn</i> , 5(1/2):131-145 (1993)	
		Panchalingam, et al., 'Molecular Tailoring of Surfaces via Pulsed RF Plasma Depositions.' Paper presented at the American Chemistry Society Symposium on Plasma Deposition of Polymeric Thin Films: Chemistry, Characterization and Applications, March 28-29 (1993), Denver, Colorado. <i>Journal of Applied Polymer Science: Applied Polymer Symposium</i> , 54:123-141 (1994), © 1994 John Wiley & Sons, Inc.	
		Wang, et al., 'Plasma Synthesis of a Novel CF ₃ -Dominated Fluorocarbon Film,' <i>Chem. Mater.</i> , 8:2212-2214 (1996)	

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